

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takahiro MATSUO et al.

Serial No.: 09/551,656  
(DIV of SN: 09/326,541)

Filed: April 18, 2000

For: PATTERN FORMING MATERIAL AND  
PATTERN FORMING METHOD



Group Art Unit: 1752

Examiner: C. HAMILTON

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JAN 25 2001  
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AMENDMENT UNDER 37 C.F.R. § 1.111

Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated October 25, 2000, having a shortened statutory period for response set to expire January 25, 2001, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 2 and 3, without prejudice, and amend claim 1 as follows: